

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

BREV 13186

Application Number

097830380

Applicant(s)


ANDRE et al

Filing Date



APRIL 25, 2001

Group Art Unit



## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,670,248	09-23-97	LAZAROV et al	428	304.4	

## FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		0 486 475 A2	03-03-89	EUROPE	C 03 C	17/23		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	"Influence of Microstructure on Laser Damage Threshold of IBS Coatings" by C. J. Stolz et al SPIE Vol. 2714 XP-002111763, pgs. 351-359
	"Thin Films for Optical Systems" edited by F.R. Flory Ecole Nationale Supérieure de Physique de Marseille, Marseille, France Pgs. 521-549

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

"Optical Coatings Deposited by Reactive Ion Plating" by A.J. Waldorf et al  
Applied Optics/October 1, 1993/Vol. 32, No. 28  
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"Optical Coatings for High-Power Neodymium Lasers" by B. Brauns et al  
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"Investigation of Optical Damage Mechanisms in Hafnia and Silica Thin Films Using Pairs of Subnanosecond Laser Pulses with Variable Time Delay"  
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"Characterization of Defect Geometries in Multilayer Optical Coatings" by R.J. Tench et al  
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"Stress and Environmental Shift Characteristics of HfO<sub>2</sub>/SiO<sub>2</sub> Multilayer Coatings" by J.F. Anzellotti et al  
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Reprinted from 28th Annual Boulder Damage Symposium proceedings "Laser-Induced Damage in Optical Materials: 1996"  
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